



divisional application of U.S. Patent Application Serial No. 08/742,895, filed November 1, 1996.—

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In the Claims:

Caricel claims 1-50.

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New Claims

51. A method of forming a plurality of DRAM capacitors comprising:

etching capacitor container openings for an array in a substrate in at least two separate etching steps, and forming electrically insulative partitions between adjacent capacitors intermediate the two etching steps.

52. The method of claim 51 wherein the forming electrically insulative partitions step comprises:

forming insulative material over the substrate; and conducting an anisotropic etch of the insulative material to a degree sufficient to leave the partitions.

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53. A processing method of forming a plurality of DRAM capacitors comprising ettning capacitor container openings for a capacitor array in a substrate in two separate etching steps.

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